Attorney Docket 0553-0246

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

În Re A	Application of:		
Koichiro Tanaka) I hereby certify that this correspondence is being deposited with the United States	
Serial No. 09/812,529) Postal Service as first class mail in an envelope addressed to:	J
Filed: March 20, 2001		Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on	4
For:	Method of Manufacturing a Semiconductor Device	Sharron Wallace	<u>.</u>
Art Un	it: 2812) Mariana Mar	 ~/
Examiner: Richard A. Booth		Pate: November 34,200	

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT H (AFTER ALLOWANCE)

Sir:

In furtherance of the Notice of Allowance, please amend the above-identified application as follows: